

Application/Control No.	Applicant(s)/Patent under Reexamination
10/075,917	KOCH, KENNETH ELMON
Examiner	Art Unit
Daniel Pan	2183

SEARCHED					
Class	Subclass	Date	Examiner		
712	223 227	11/8/2007	DP		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
		11/8/2007	DP ·	
	searched on FPGP	11/8/2007	DP	

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
west pgp uspat jpoabs derwent IEEE IBM TD NPL 716/18, 326/41,114,125 AND OR 712/225 714/724,741, 703/15	11/8/2007	DP